

Notice of References Cited	Application/Control No. 10/825,528	Applicant(s)/Patent Under Reexamination SHEN ET AL.	
	Examiner Anthony Weier	Art Unit 1761	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,811,804	11-2004	Patel et al.	426/598
*	B	US-2005/0202147	09-2005	Wong et al.	426/598
*	C	US-6,221,419	04-2001	Gerrish, Timothy C.	426/577
*	D	US-4,039,696	08-1977	Marquardt et al.	426/598
*	E	US-5,658,609	08-1997	Abboud et al.	426/609
*	F	US-6,861,080	03-2005	Kent et al.	426/36
*	G	US-2004/0258827	12-2004	Shen, Cheng	426/598
*	H	US-6,303,160	10-2001	Laye et al.	426/36
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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